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*Kathryn L. L...*  
Signature

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**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gilyong Chung  
Chin Che Tin  
John R. Williams  
Kyle McDonald  
Massimiliano Di Ventra  
Robert A. Weller  
Sokrates T. Pantelides  
Leonard C. Feldman

Group Art Unit: 2812

Examiner: Unknown

Atty. Dkt. No.: 2026.000900/RCF

Serial No.: 09/818,913-<sup>193</sup>

Filed: 03/26/2001

For: INCLUSION OF NITROGEN AT THE  
SILICON DIOXIDE-SILICON CARBIDE  
INTERFACE FOR PASSIVATION OF  
INTERFACE DEFECTS

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**CHANGE OF CORRESPONDENCE ADDRESS**

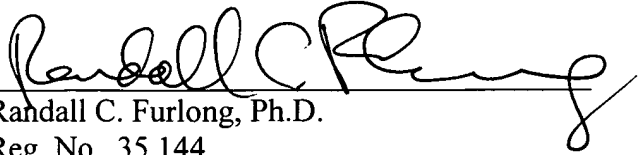
Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Please direct all future communications regarding this application as follows:

Randall C. Furlong, Ph.D.  
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Respectfully submitted,

A handwritten signature in black ink, appearing to read "Randall C. Furlong", written over a horizontal line.

Randall C. Furlong, Ph.D.  
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Attorney for Applicants

Date: September 19, 2001